

## PATENT APPLICATION

Sheet 1 of 2

FORM PTO-1449		ATTY. DOCKET NO.	APPLICATION NO.	CONFIRMATION NO.
		10030279-1	10/607,655	
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT		APPLICANT		
(Use several sheets if necessary)		Christopher L. Coleman		
		FILING DATE	GROUP	
		H r with	2872	

## REFERENCE DESIGNATION

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	PUBLICATION DATE	NAME	Pages, Columns, Lines Where Relevant Passages or Figures Appear
<i>me</i>	1A	2002/0075911	Jun. 20, 2002	Cham et al.	
<i>me</i>	1B	2002/0191394	Dec. 19, 2002	Coleman et al.	
	1C				
	1D				
	1E				
	1F				
	1G				
	1H				
	1I				
	1J				
	1K				

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE OR APPLICANT	Pages/Columns/Lines Where Relevant Passages/Figures Appear	Check if Translation attached
	1L					
	1M					
	1N					
	1O					
	1P					

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

<i>me</i>	1Q	CEPAC, Inc. Technical Publication entitled "Topics in Sputter Deposition"; Volume 6, Issue 3, July-September 1996; 4 pgs. Available at <a href="http://www.cerac.com/pubs/cmn/cmn6_3.htm">http://www.cerac.com/pubs/cmn/cmn6_3.htm</a> . (© 1996)
<i>me</i>	1R	IBM, Inc. article entitled "Sputter Deposition for Semiconductor Manufacturing"; Volume 43, 1999; 14 pgs. Available at <a href="http://www.research.ibm.com/journal/rd/431/rossagel.html">http://www.research.ibm.com/journal/rd/431/rossagel.html</a> .
<i>me</i>	1S	CERAC, Inc. Coating Material News article entitled "Common Deposition Techniques"; Volume 12, Issue 1, March 2002; 4 pgs.

EXAMINER

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*7/21/04*

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Sheet 2 of 2

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2N					
2O					
2P					

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

2Q	IC Knowledge technical brief entitled "Fundamentals of Sputter Deposition"; 1 pg. (© 2002).  <i>Ar</i>
2R	Breault Research Organization, Inc. Technical Guide entitled "Diffraction Gratings and DOEs"; 63 pgs.; August 2002. (© 1999).  <i>Ar</i>
2S	MicroMagazine.com online article by Andy Bavin, Trikon Technologies, entitled "Controlling Particles in Sputter Deposition Modules"; 11 pgs. (© 1997-2003).  <i>Ar</i>

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7-21-2004